## Notice of References Cited

Application/Control No. 10/533,441	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.		
Examiner	Art Unit		
Bernard E. Souw	2881	Page 1 of 1	

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2003/0104627	06-2003	Takayama et al.	435/459
*	. В	US-2003/0080302	05-2003	Yashiro, Hidehiko	250/504.00R
*	С	US-2002/0172317	11-2002	Maksimchuk et al.	376/190
*	D	US-6,767,743	07-2004	Takayama et al.	435/459
*	E	US-6,724,004	04-2004	Yashiro, Hidehiko	250/504R
*	F	US-6,909,764	06-2005	Maksimchuk et al.	376/190
*	G	US-5,420,436	05-1995	Seya et al.	250/492.1
	н	US-			
	ı	US-			
	J	US-			
	К	US-		×	
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N ·					
	0					
	Р					
	Q					
	R					
	S			·		
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Backus et al., "High Power Ultrafast Lasers", Rev. Sci. Instruments 69 (3), 1998, pg. 1207-1223
	>	Group for High Energy Physics, Institute of Physics, Chinese Academy of Sciences 2003, <a href="http://highfield.iphy.ac.cn/L05/Research.html">http://highfield.iphy.ac.cn/L05/Research.html</a>
	W	
	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.